



# TID Influence on the SEE sensitivity of Active EEE components

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# Purpose of the study

**During space application, devices are subject to TID and SEE at the same time.**

**But parts radiation qualification process includes both ionizing dose and SEE tests, performed independently**

**⇒ Synergistic effects between Dose and SEE on electronic devices ?**

## ■ SRAM :

- An increase of soft error rate is observed when it is measured with the same pattern used during Total Dose irradiation and a decrease for the complementary pattern.  
*Koga 2009*

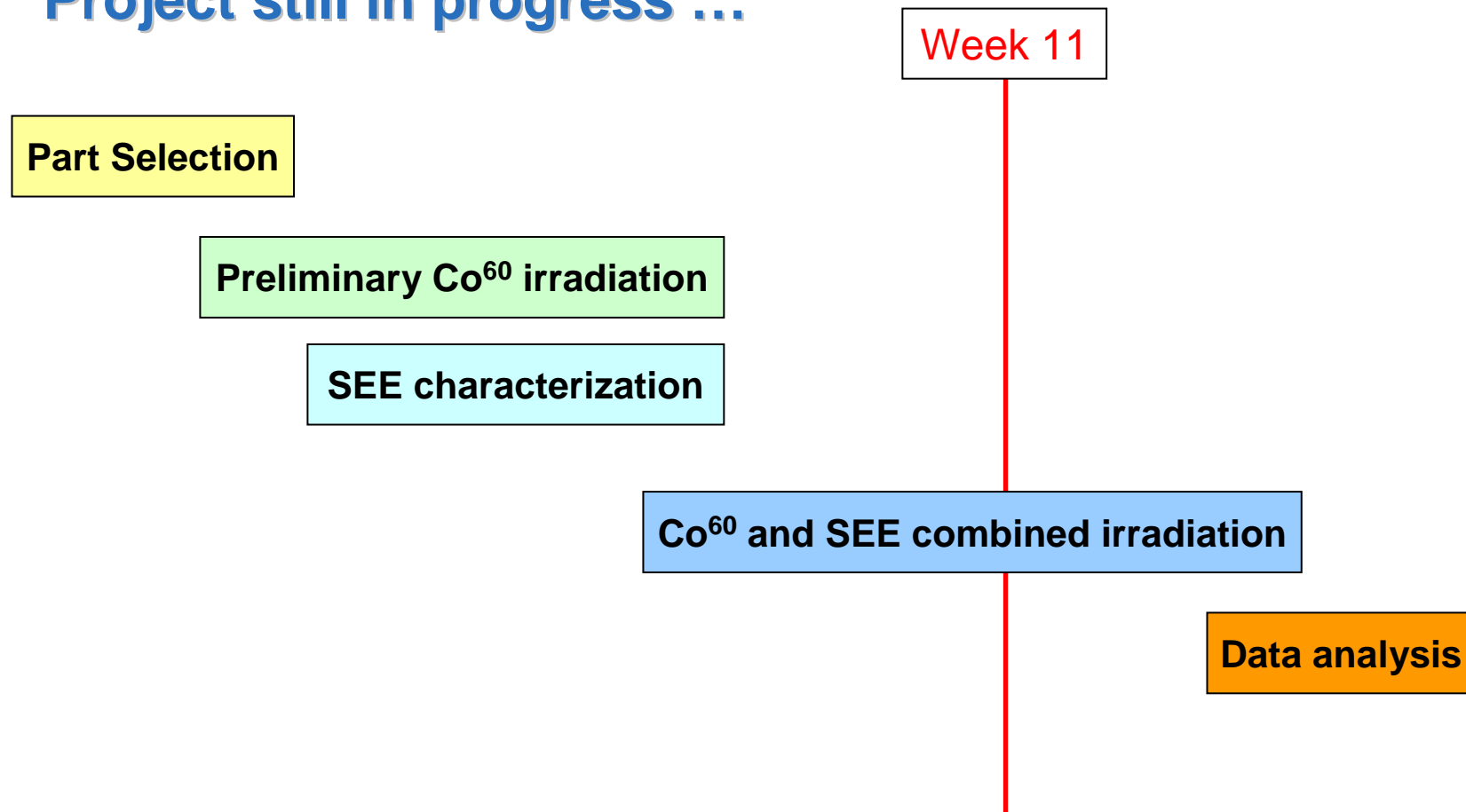
## ■ NAND Flash:

- The cross section for single bit upsets in Floating Gate cells increases if the sample has been previously exposed to even relatively low TID levels. *Bagatin 2010*

## ■ ADC & DAC :

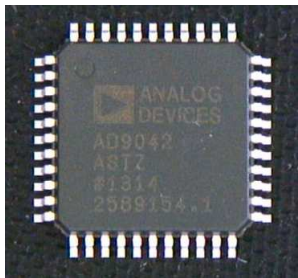
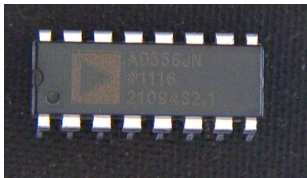
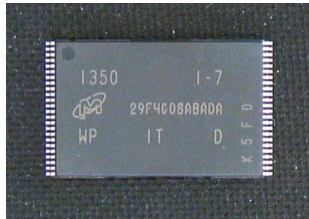

- To our knowledge these effects have not yet been published in open literature

**Project still in progress ...**



# Devices under test

## Four different devices under test

|                     | <b>AD9042</b>   | <b>AD558</b>   | <b>MT29F4G08AAC</b>   | <b>R1RW0416</b>   |
|---------------------|---|--|---|---|
| <b>Manufacturer</b> | <b>Analog Device</b>  | <b>Analog Device</b>   | <b>Micron</b>   | <b>Renesas</b>  |
| <b>Date code</b>    | <b>1314</b>   | <b>1116</b>  | <b>1346</b>   | <b>1350</b>   |
| <b>Type</b>         | <b>ADC 12bit</b>  | <b>DAC 8bit</b>  | <b>NAND flash</b>   | <b>SRAM 16Mb 8bit</b>   |
|                     |  |  |  |  |
| <b>Effects</b>      | <b>SEU, SET, SEL</b>  | <b>SET, SEL</b>  | <b>SEU, MBU, SEL, SEFI</b>  | <b>SEU, MBU, SEL</b>  |

The device has been selected in order to have different functions, manufacturers and technologies

# Preliminary $^{60}\text{Co}$ test

| Step                | 1   | 2 | 3  | 4  | 5  | 6  | 7  | 8   | 9   | 10  | 11  |
|---------------------|-----|---|----|----|----|----|----|-----|-----|-----|-----|
| Total Dose krad(Si) | 0   | 5 | 10 | 20 | 30 | 50 | 70 | 100 | 150 | 200 | 250 |
| Dose rate rad(Si)/h | 310 |   |    |    |    |    |    |     |     |     |     |

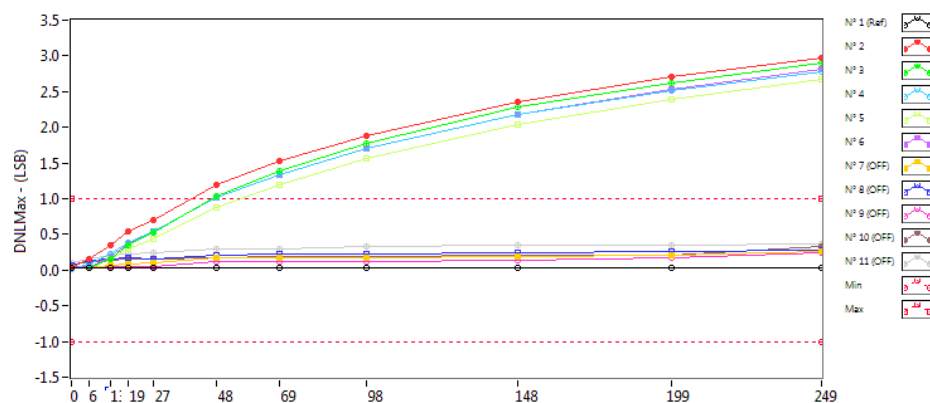
- **5 ON + 5 OFF + 1 reference sample**

- **TRAD  $^{60}\text{Co}$  GAMRAY Facility**

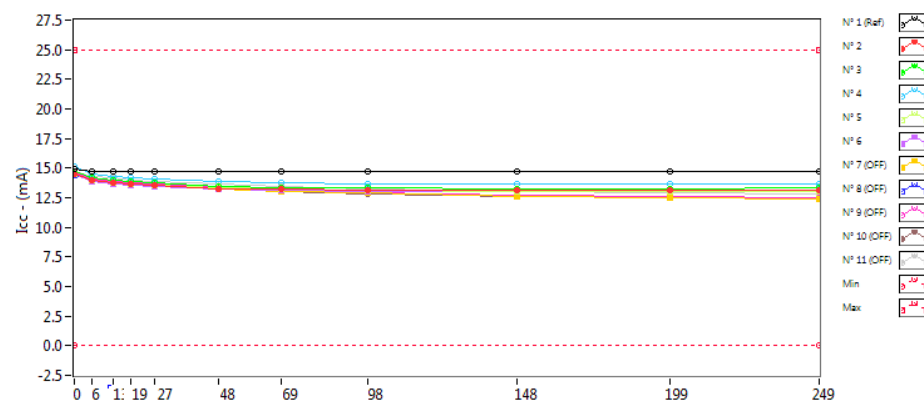
⇒ **Devices behavior under total dose**

⇒ **Total dose level and dose steps for each reference for the combined  $^{60}\text{Co}$  and SEE tests.**

## DAC AD5558



Differential nonlinearity MAX

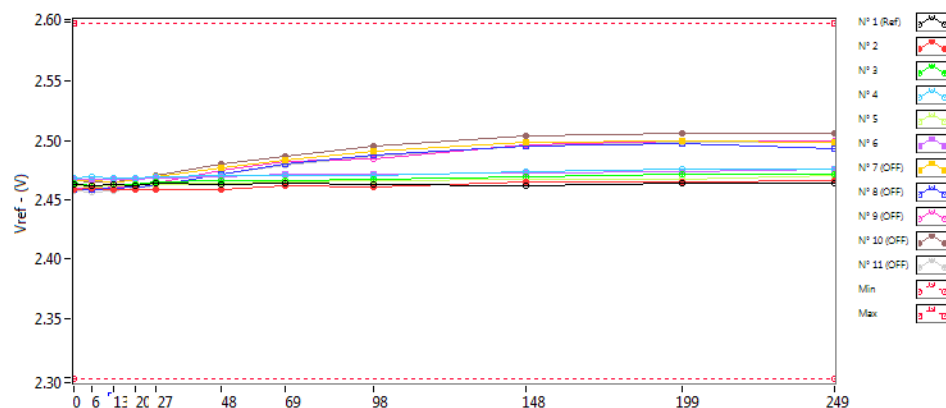


Power supply current

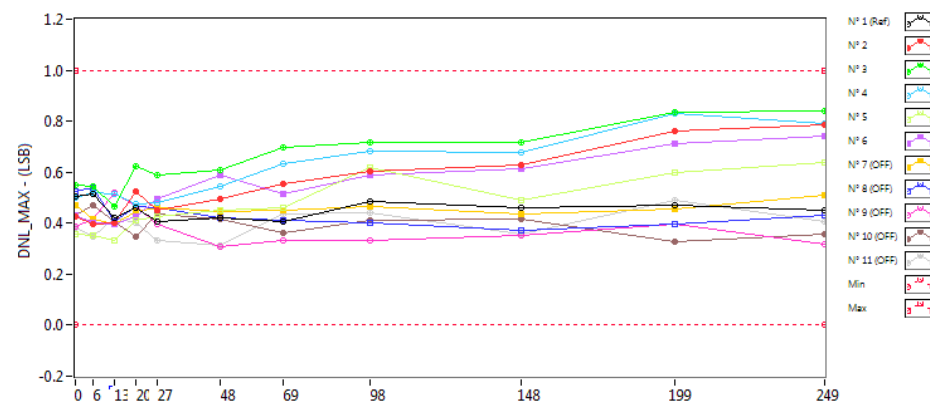
⇒ Difference between ON and OFF parts

⇒ Functional at 250krad(Si)

## ADC AD9042



Voltage reference

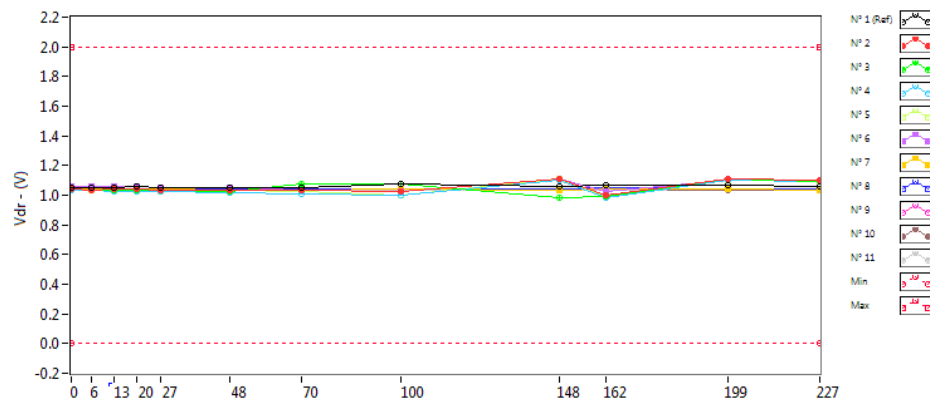


Differential non-linearity MAX

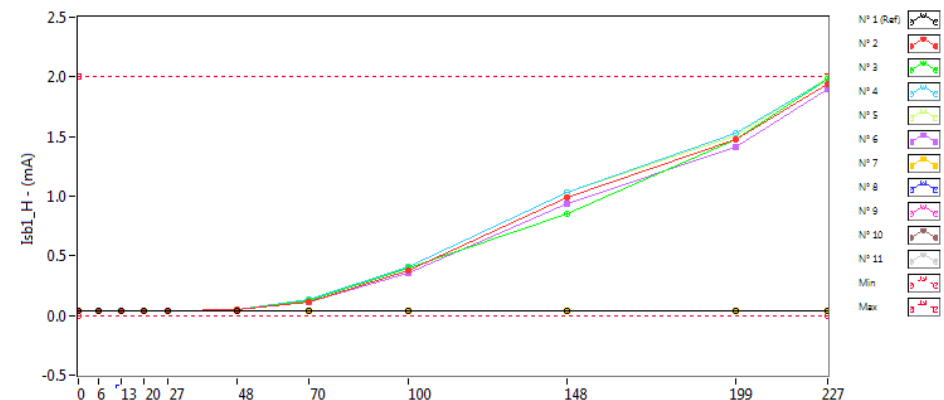
⇒ **Difference between ON and OFF parts**

⇒ **Functional at 250krad(Si)**

## SRAM R1RW0416



Data Retention Voltage



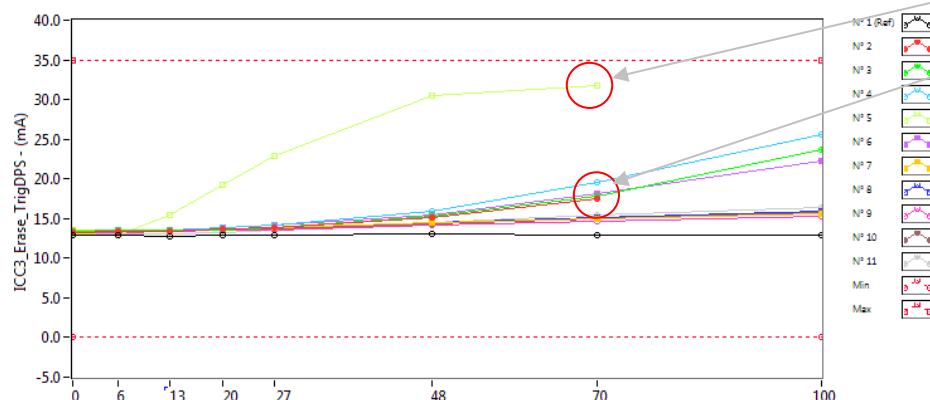
Standby power supply current

⇒ **Difference between ON and OFF parts**

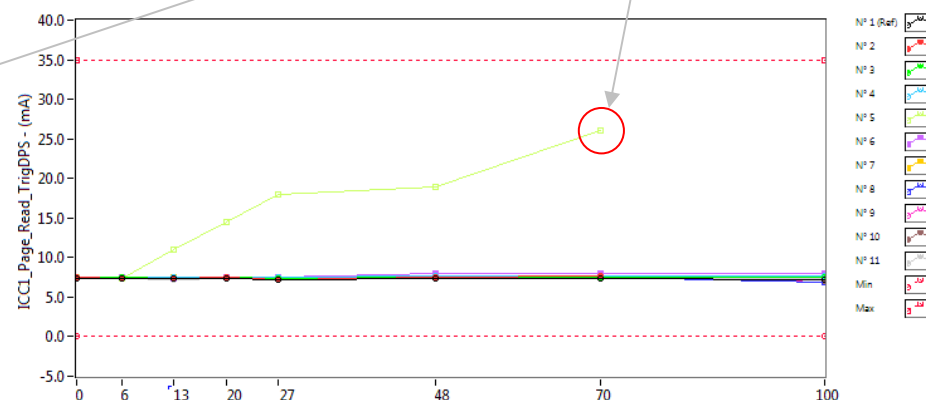
⇒ **Functional at 250krad(Si)**

## NAND FLASH MT29F4G08AAC

At the step of 100krad, two devices (N°2 & N°5) are not measurable



ERASE current



Sequential READ current

⇒ Difference between ON and OFF parts

⇒ Not Functional at 150krad(Si)

# Combined $^{60}\text{Co}$ and SEE test

**Preliminary dose characterization allowed to define total dose level and dose steps for each reference**

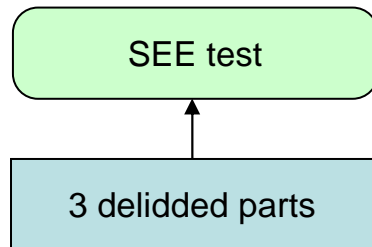
|                             |                     |    |      |    |       |     |
|-----------------------------|---------------------|----|------|----|-------|-----|
| AD558<br>AD9042<br>R1RW0416 | Step                | 1  | 2    | 3  | 4     | 5   |
|                             | Total Dose krad(Si) | 0  | 37.5 | 75 | 112.5 | 150 |
|                             | Dose rate rad(Si)/h | 74 |      |    |       |     |

|              |                     |    |      |      |     |
|--------------|---------------------|----|------|------|-----|
| MT29F4G08AAC | Step                | 1  | 2    | 3    | 4   |
|              | Total Dose krad(Si) | 0  | 33.3 | 66.6 | 100 |
|              | Dose rate rad(Si)/h | 66 |      |      |     |

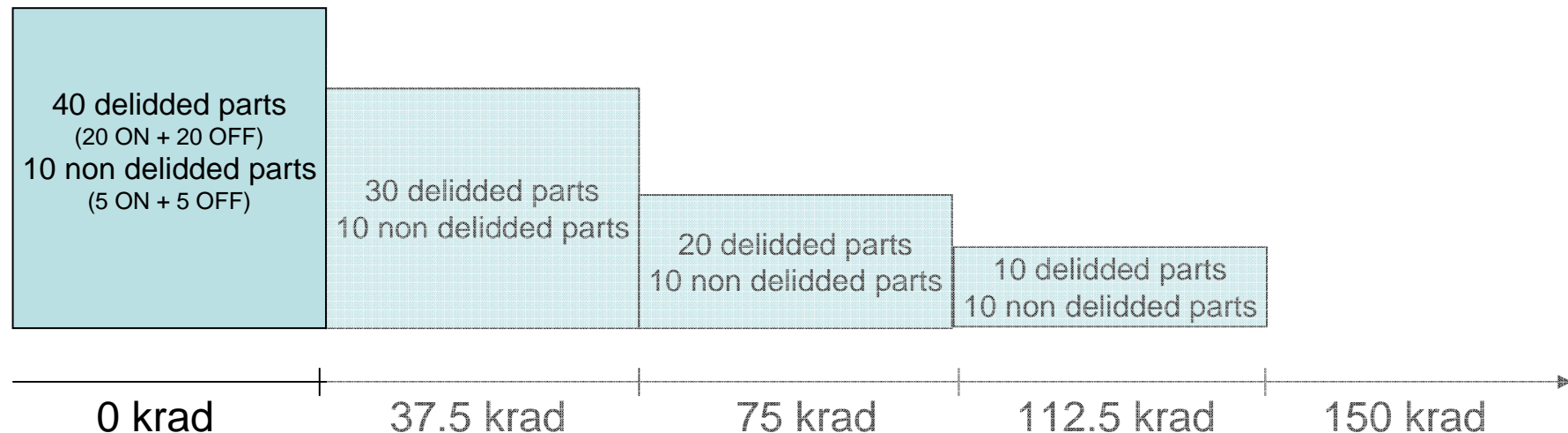
**Université Catholique de Louvain (UCL)  $^{60}\text{Co}$  Gamma Irradiation Facility (GIF)**

# Combined $^{60}\text{Co}$ and SEE test

## Step 1: 0 krad(Si)



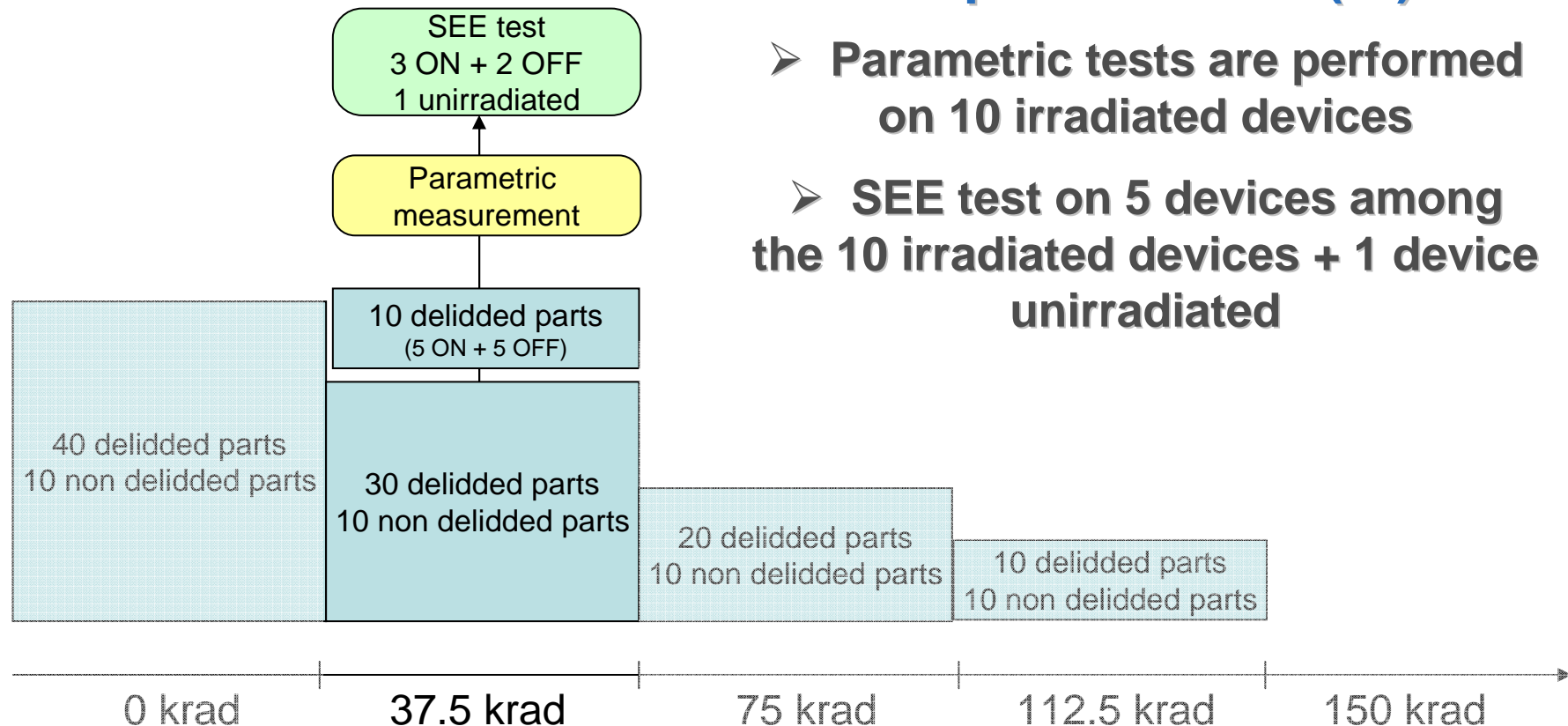
- Parametric tests are performed on all devices before  $^{60}\text{Co}$  irradiation
- SEE test on 3 delidded devices



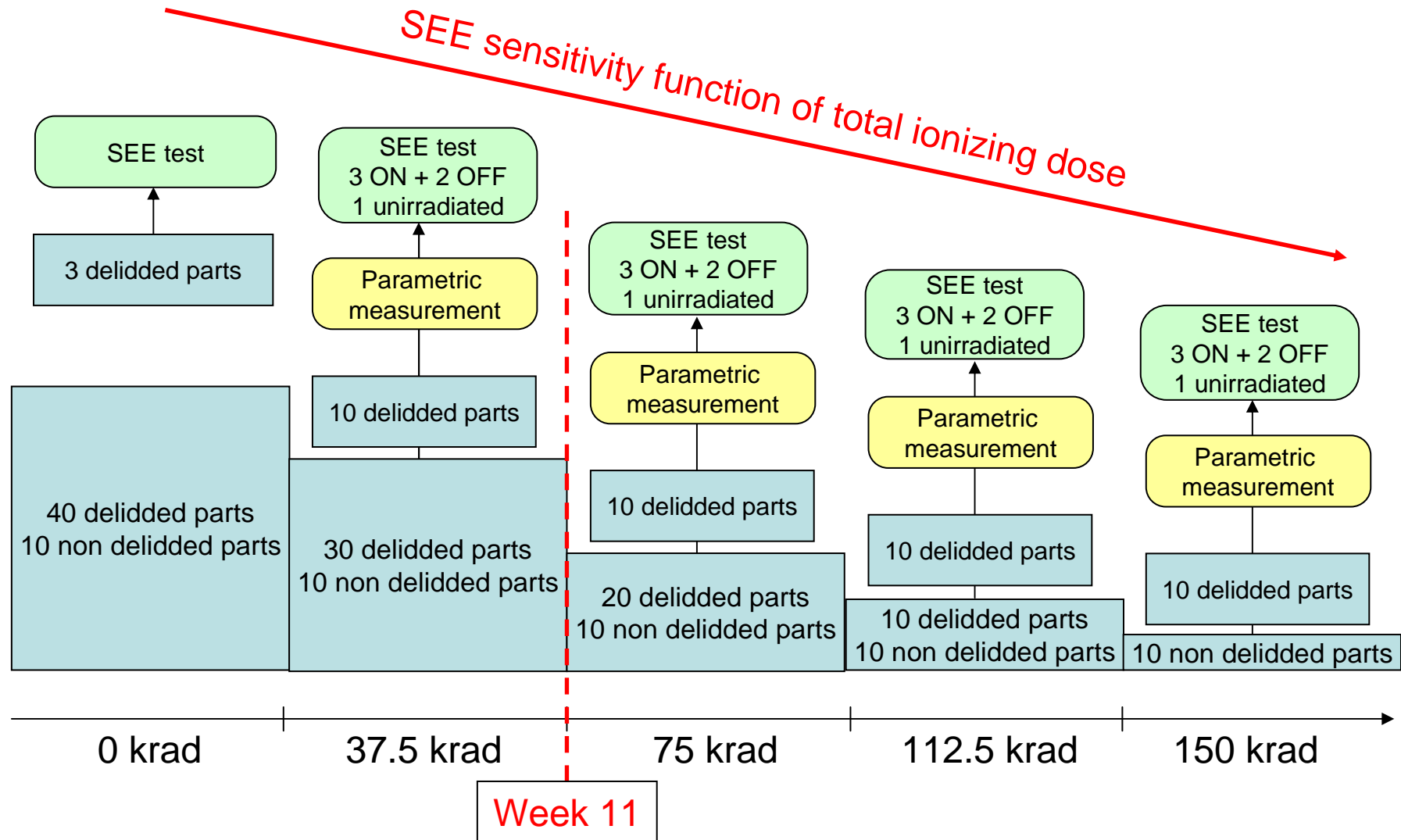
# Combined $^{60}\text{Co}$ and SEE test

## Step 2: 37.5 krad(Si)

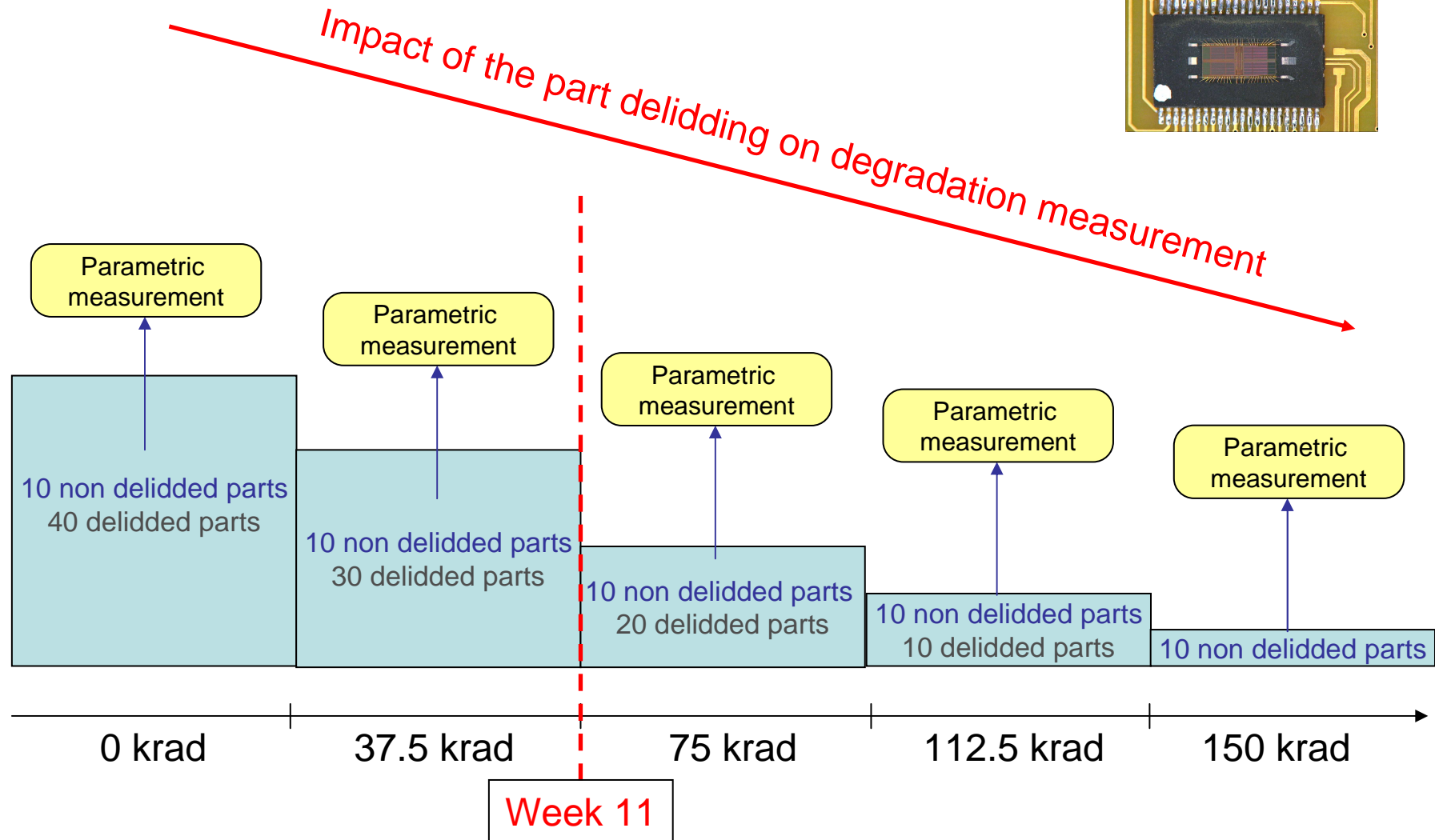
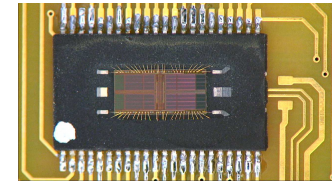
- Parametric tests are performed on 10 irradiated devices
- SEE test on 5 devices among the 10 irradiated devices + 1 device unirradiated



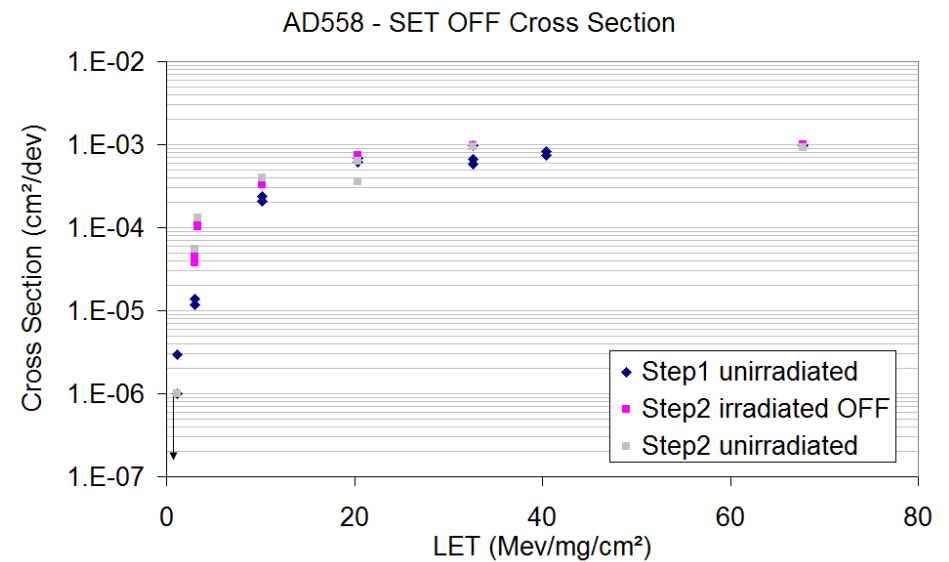
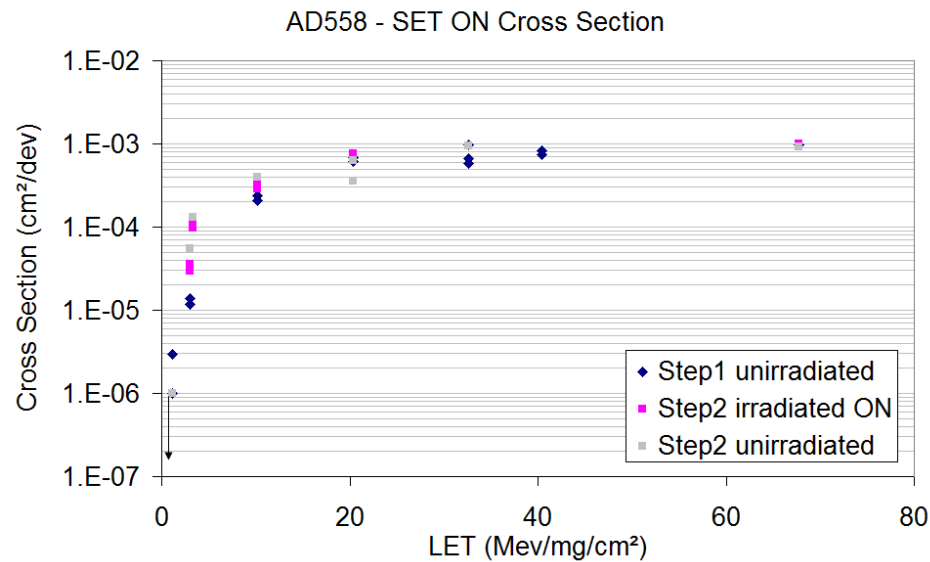
# Combined $^{60}\text{Co}$ and SEE test



# Combined $^{60}\text{Co}$ and SEE test



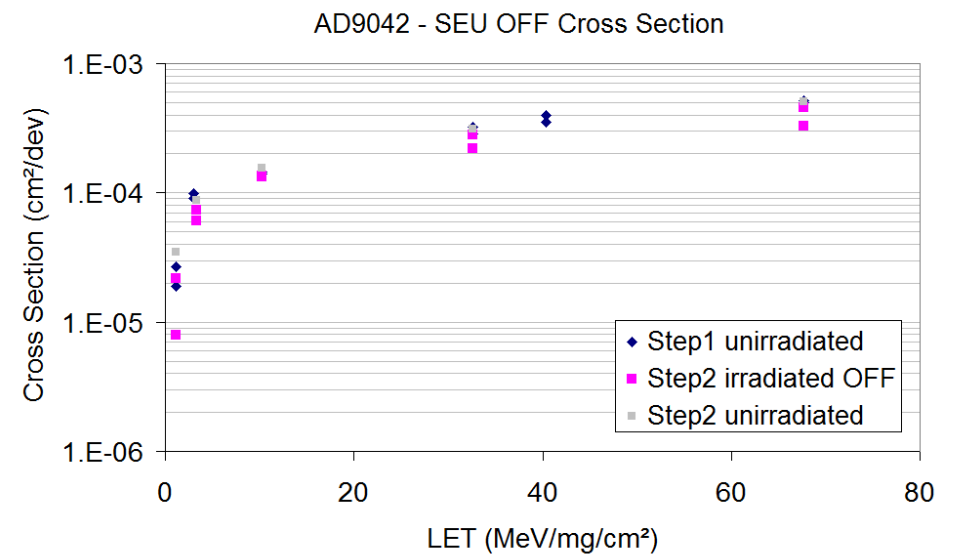
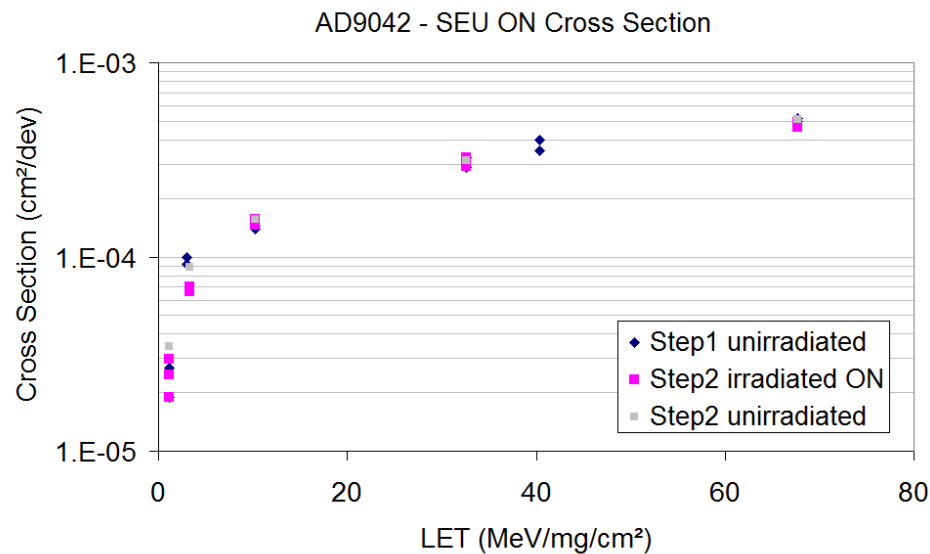
## DAC AD558 : Step2 = 37.5krad



⇒ No difference between ON and OFF parts

⇒ No Synergy effect at 37krad(Si)

## ADC AD9042 : Step2 = 37.5 krad

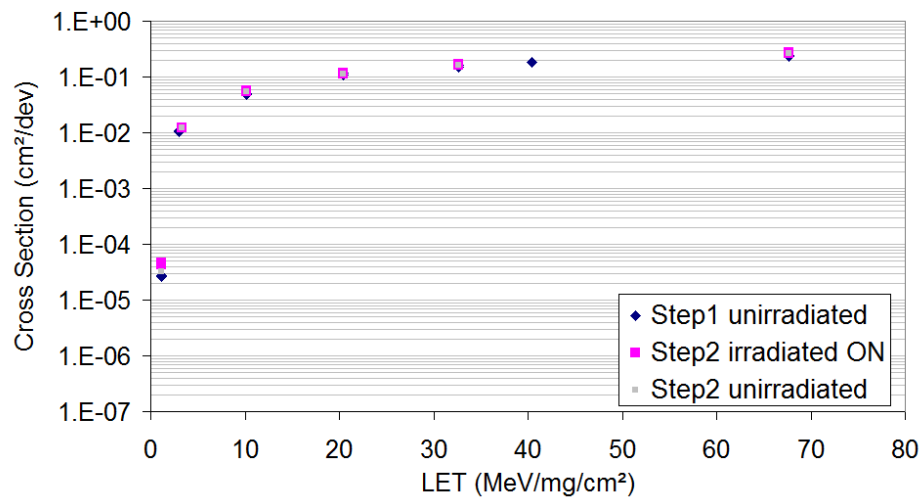


⇒ No difference between ON and OFF parts

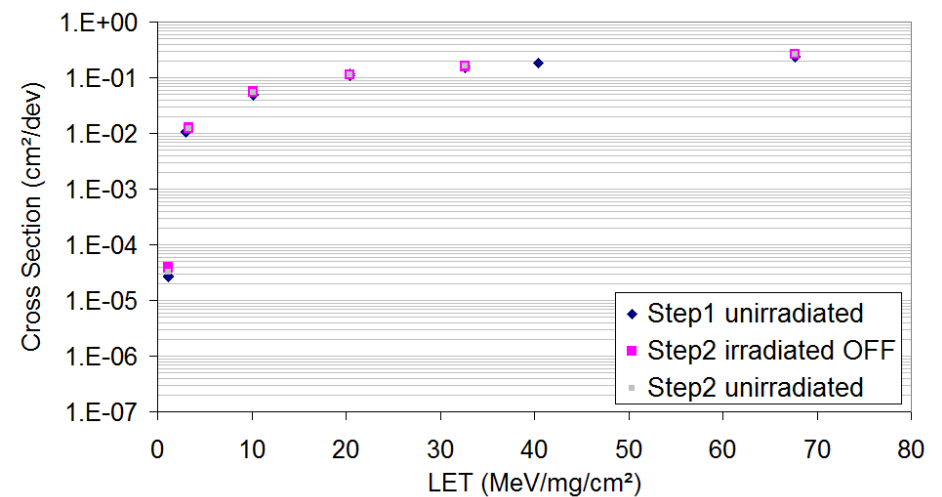
⇒ No Synergy effect at 37krad(Si)

## SRAM R1RW0614 : Step2 = 37.5 krad

R1RW0416 - SEU ON Cross Section



R1RW0416 - SEU OFF Cross Section

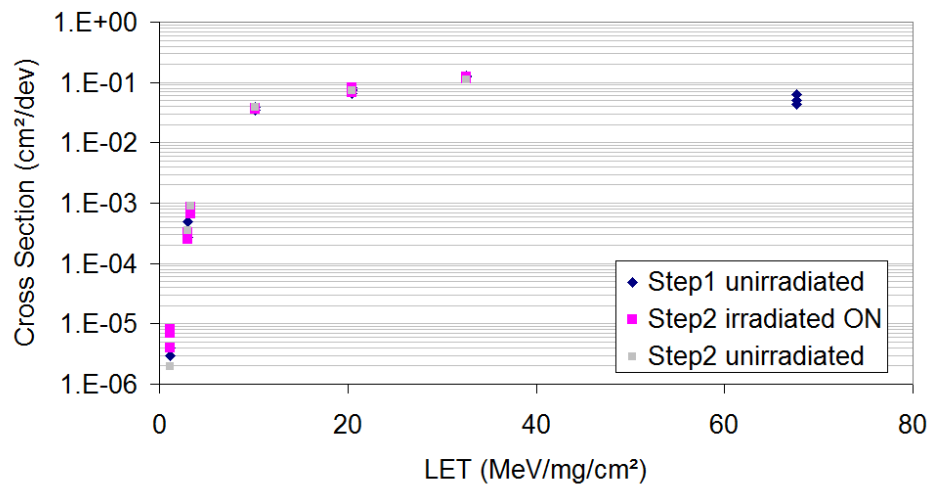


⇒ No difference between ON and OFF parts

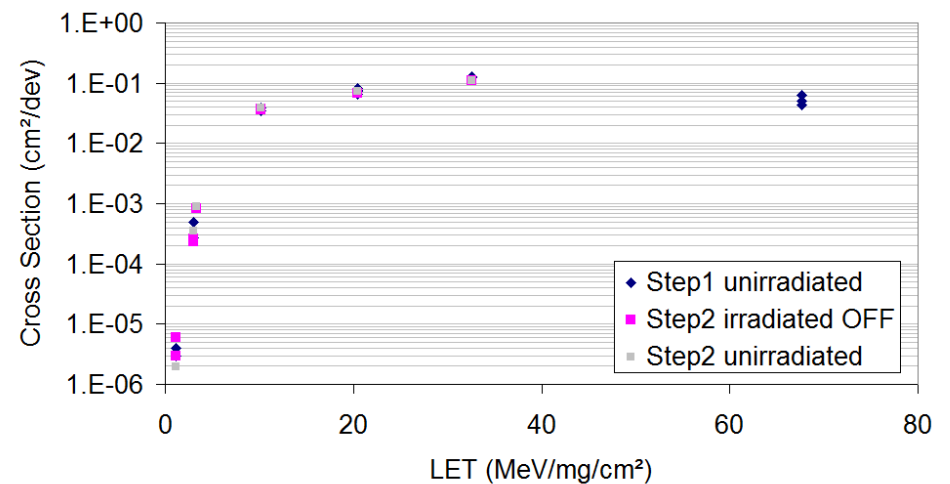
⇒ No Synergy effect at 37krad(Si)

## NAND FLASH MT29F4G08AAC : Step2 = 33.3 krad

MT29F4G08ABADA SEU ON Cross Section



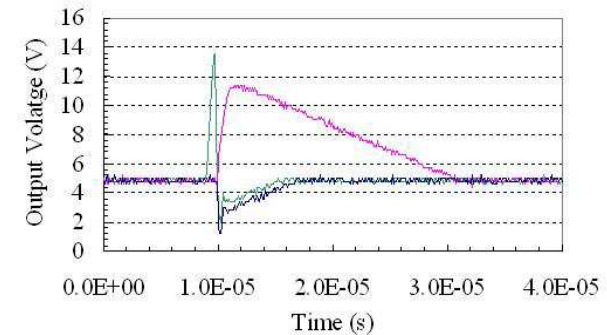
MT29F4G08ABADA SEU OFF Cross Section



⇒ No difference between ON and OFF parts

⇒ No Synergy effect at 37krad(Si)

- **Impact of TID on SET shape**



- **Imprint effect on SRAM**

- During the  $^{60}\text{Co}$  total dose irradiation AA pattern is written at all addresses
- the SEU test pattern is AA in half of the memory array, and the complementary pattern 55 in the other half

- **Impact of TID on SEFI signature ...**

- **Impact of TID on SEL sensitivity**

**Up to now, no impact of TID on SEE sensitivity,**

**But ...**

**The project is still in progress**

# TID Influence on the SEE sensitivity of Active EEE components

## QUESTIONS

